

THERMOELECTRIC HETROSTRUCTURE ASSEMBLIES ELEMENTBackground of the Invention

Reference to Prior Related Provisional Application

This application is related to and claims the benefit of the filing of U.S. Provisional Application No. _____, entitled Thermoelectric Hetrostructure Assemblies Element, filed October 24, 2001.

Field of the Invention

The following disclosure relates generally to thermoelectrics configured from hetrostructures or thin layers of thermoelectric material to improve performance or usability of such thermoelectrics.

Description of the Related Art

The bulk properties of thermoelectric (TE) materials can be altered if the materials are formed from very thin films or segments of alternating materials. The resultant assemblies formed of segments of such thin films are usually called hetrostructures. Each film segment is the order of tens to hundreds of angstroms thick. Since each segment is very thin, multiple segments are needed to fabricate cooling, heating and power generating devices. The shape, dimensions and other geometrical characteristics of conventional hetrostructures often make attachment of suitable thermal heat transfer members and electrodes to the individual hetrostructures assembly difficult. Further complications arise in the extraction of thermal power from the structures. New fabrication techniques, material combinations, and forming methods are required to fabricate TE elements from such materials. New fabrication techniques are even more critical for systems made from thousands of segments since materials formed of many segments tend to be fragile and weakened by (1) internal stresses that result from fabrication, (2) the very nature of the materials and (3) internal weakness caused by contamination and process variation. Further, certain TE materials, such as those based on Bismuth/Tellurium/Selenium mixtures, are inherently mechanically weak and hence, fragile in hetrostructure form.

Hetrostructure TE materials generally are configured to be long in one dimension (e.g., wires) or two dimensions (e.g., plates). The TE materials are usually anisotropic with

varying thermal, electrical, and mechanical properties along different axes. Electric current either flows parallel to a long dimension or perpendicular to the long dimension(s). In TE elements where the current flows parallel to the long dimension, the length can range up to thousands of times the thickness or diameter of the material. To achieve the desired performance, such TE elements can be made of a multiplicity of hetrostructure wires or plates.

Summary of the Invention

Various embodiments using heterostructures in forming thermoelectric elements are disclosed. The hetrostructures are constructed with layers of bonding and/or intermediate materials that add strength and/or improve manufacturability of completed thermoelectric elements formed of the hetrostructures. In addition, the bonding and intermediate materials are used in various manners to facilitate or enhance the operation of thermoelectric assemblies. The thickness of the intermediate and bonding materials take into account the desired thermal and electrical characteristics and attributes for the particular configuration or application. Both the thermal conductivity and thermal conductance can be taken into account, in considering the thickness of each bonding and intermediate material.

Several configurations for thermoelectrics are described. One configuration involves a thermoelectric element that has at least two hetrostructure thermoelectric portions of the same conductivity type (such as N-type or P-type). It should be noted that the use of the term "same conductivity type" in this configuration does not mean that these portions need to be of the same material, nor doping concentration. An electrically conductive material is coupled to the thermoelectric portions to form at least one electrode.

Preferably, the hetrostructure thermoelectric portions form layers in the thermoelectric element, and the electrically conductive material is coupled to at least one of the layers at at least one end of the layers. Preferably, the conductive material couples to all or substantially all of the layers, where the electrode is an end electrode. Alternatively, the electrically conductive material may be coupled to at least the top or bottom of the layers.

In one configuration, the hetrostructure thermoelectric portions form wires or a wire bundle, and the electrically conductive material forms at least one electrode at the end of the wire bundle. Preferably, an electrode is provided for each end. Alternatively, the electrically

conductive material is coupled to at least the top or bottom of the wire bundle, or separate electrodes are provided for the top and bottom of the wire bundle.

In one example, a bonding material is between the at least two hetrostructure thermoelectric portions. The bonding material is advantageously configured to reduce the power density or the shear stress in the element, or both.

An intermediate material may also be provided between the hetrostructure thermoelectric portions and respective electrodes. Advantageously, the intermediate material is configured to reduce shear stress in the hetrostructure thermoelectric portions when the thermoelectric element is operated. For example, the intermediate material may be resilient.

In one example, the hetrostructure thermoelectric portions are of substantially the same thermoelectric material. The hetrostructure thermoelectric portions may also be constructed of at least two layers of hetrostructure thermoelectric material.

Another example of a thermoelectric element described has at least two layers of substantially the same thermoelectric material of the same conductivity type. At least one electrically conductive material is coupled to the thermoelectric material to form at least one electrode. In one form, the electrically conductive material is coupled to the layers at at least one end of the layers. Preferably, an electrode is provided at at least two ends. Alternatively, the electrically conductive material is coupled to at least the top or bottom of the layers, forming top and bottom electrodes. The layers may also form wires, with the electrodes coupled to the wires at at least one end of the wires, or coupled to at least the top or bottom of the wires.

In this example, a bonding material may also be provided between the at least two layers. Advantageously, the layers and the bonding material are configured to reduce the power density of the thermoelectric. The layers and the bonding material may be configured to reduce shear stress as an alternative, or in addition to, reducing the power density.

An intermediate material may also be provided between at least one electrode and at least one layer of the thermoelectric material. Preferably, the intermediate material is also configured to reduce shear stress in the layers. In one configuration, the intermediate material is resilient.

The at least two layers may also be hetrostructures, as with the previous example. The hetrostructures themselves may be made from at least two layers of hetrostructure thermoelectric material.

Also disclosed is a method of producing a thermoelectric device involving the steps of layering at least two hetrostructure thermoelectric segments, and connecting at least one electrode to the segments to form at least one thermoelectric element.

The step of layering may comprise bonding the at least two hetrostructure thermoelectric segments with a bonding material. A further step of providing an intermediate material between at least one of the at least two hetrostructure thermoelectric segments and at least one electrode may be used.

Preferably, the layers and/or the bonding and/or intermediate materials are configured to decrease power density. One or another, or all, may be configured to reduce shear stress as well, and/or reducing the power density.

Another method of producing a thermoelectric device involves the steps of forming at least two layers of substantially the same thermoelectric material, and connecting at least one electrode to at least one of the layers. Preferably, the step of forming involves bonding the at least two layers with a bonding material.

Advantageously, as mentioned above, the bonding material is configured to decrease power density and/or shear stresses. Similarly, an intermediate layer may be provided between the layers and the electrodes.

Brief Description of the Drawings

Figure 1 illustrates a thermoelectric element constructed of thermoelectric hetrostructures.

Figure 2 illustrates a thermoelectric wire bundle assembly.

Figure 3 illustrates a portion of a thermoelectric element.

Figure 4 illustrates thermoelectric element assembly of hetrostructures.

Figure 5 illustrates a thermoelectric element portion of a hetrostructure.

Figure 6 illustrates a thermoelectric element portion.

Figure 7 illustrates another thermoelectric element.

Detailed Description of the Preferred Embodiment

Several embodiments of thermoelectrics are disclosed where layers of hetrostructure thermoelectric materials or thin layers of thermoelectric material form a thermoelectric element. Advantageously, the layers are of the same conductivity type (N-type or P-type) for each thermoelectric element. In one embodiment, the layers are of the same, or at least substantially the same, thermoelectric material. Where the layers are hetrostructures, the hetrostructures themselves may be formed of layers of thermoelectric material. The layers may be bound together with agents that improve structural strength, allow electrical current to pass in a preferred direction, and minimize adverse effects that might occur to the thermoelectric properties of the assembly by their inclusion. Fabrication of useful TE systems requires a careful understanding of the TE materials' individual properties, such as thermal conductivity, electrical conductivity, coefficient of thermal expansion, properties over the processing and operating temperature ranges, and long-term stability. Often properties associated with other materials used in assembly of TE elements also can affect performance. Often interfacial diffusivity, work function, bond strength and the like are characteristics that arise from the use of combinations of materials and can affect performance.

In systems where the preferred direction of current flow is parallel to a long dimension (e.g., along a bundle of wires or along the long direction of plates), a bonding material for the hetrostructures or thermoelectric layers advantageously has low thermal and electrical conductivity, high adhesive strength, and stable general properties that do not change during use.

For systems where the current flows perpendicular to the long dimensions, such as through hetrostructures or thermoelectric material layers forming plates, preferred binding agents have high electrical conductivity so that electric current passes through the material with little resistive loss. Preferably, this is achieved by the binding agent wetting the TE materials' surfaces either directly, or through the use of an intermediate compatible wetting agent. Advantageous binding agents also do not degrade the performance of the resultant system either by requiring high fabrication temperatures that could cause diffusion in the TE hetrostructure or promote degradation with time through diffusion, ionic exchange, corrosion or other mechanisms. Figure 1 depicts a TE 100 constructed of TE hetrostructure plates 101

terminated at each end with electrodes 102, 103. The layered plates 101 are assembled with a bonding material 104. The TE 100 may make up one leg or element of a TE module, and is either N or P conductivity type TE material. Generally, many such TE elements are arrayed so that current 105 flows alternately between N and P type materials, with electrodes 102 and 103 making part or all of the current flow path between TE elements 100.

At a first interface between the electrode 102 and the TE plates 101, thermal energy, for example, is removed and at the second interface between other electrode 103 and the TE plates 101 in this example, thermal energy is absorbed. Thus, electrode 102 is cooled and electrode 103 is heated. In normal heating or cooling operation, the heated electrode 103 is hotter than the cooled electrode 102 so that heat flows from electrode 103 to electrode 102. In power generation operation, a temperature gradient applied across the electrodes causes current to flow. Advantageously, the properties of the TE plates 101 and bonding material 104, the current 105 and the overall dimensions are chosen to minimize the combination of the resultant conductive heat loss and Joule heating from the current 105 passing through the TE element 100 so as to maximize cooling or thermoelectric efficiency, or power generation as is known in the art.

The bonding material 104 attaches the thin TE plates 101 into a slab that can be further processed (i.e., to connect electrodes 102 and 103 with greater ease). Note, however, the bonding material 104 conducts heat and thereby degrades the overall performance of the TE element 100. Advantageously, therefore the bonding material 104 should have poor thermal conductivity. It could be an unfilled epoxy and should be in as low a proportion as possible to the TE plates 101. Further it should not degrade with time, and should not reduce in other ways the TE system's thermal performance. Similarly, the bonding material 104 should not conduct electrical current to the extent that such conductance measurably increases Joule heating or causes current to bypass the TE plates 101. However, it is noted that some degree of electrical conductivity in the bonding material 104 can be of benefit in assemblies as noted below in connection with the description of Figure 7.

Figure 2 depicts a TE element 200 in which the end electrodes 203 and TE wires 205 or wire bundle are in contact with an intermediate conductor 202. The wire assembly 201 has a bonding material 206 and a sheath 207 around the wire bundle 205.

Finally, the electrodes 203 could be placed on the top and/or bottom of the wires rather than forming end electrodes.

Figure 3 depicts a portion of a TE element 300 that has a lower electrode 305, an intermediate conductor material 304, a first diffusion barrier 302 and TE material 301, in plate form. The TE material 301 is depicted as three layers for convenience; in actual TE elements it could be of any number of layers and could have bonding materials (not shown) between the layers as in Figure 1, to electrically and uniformly connect them. (Alternatively, a material constituent of the heterostructure TE material 301 itself would make the connection if the assembly were suitably processed (such as with heat and pressure). A second diffusion barrier 302 attaches to another intermediate material 304, which attaches to an upper electrode 303. In the example, a current 306 passes from the lower electrode 305 through, the layer and to the upper electrode. Since current passes through the intermediate material 304 and the diffusion barriers 302, advantageously, both are of high electrical and thermal conductivity since the materials are in series with the TE material 301. Thus, the criterion is the same as for the intermediate material 202 of Figure 2, but the opposite of the bonding material 104 and 206 of Figures 1 and 2.

Figure 4 depicts a portion of a TE element 400. A first portion consists of an upper electrode 401, an intermediate material 402, TE material 403, an intermediate material 404 and a lower electrode 405. The second TE element consists of an upper electrode 407, and intermediate material 408, TE material 409, an intermediate material 410 and a lower electrode 411. Solder 406 or other conductive material is between the lower electrode 405 and the upper electrode 407.

As an example of operation, current 412 passes from the lower electrode 411 through the TE assembly 400 to the upper electrode 401. In this embodiment of the invention, two TE portions both of either N or P conductivity type TE material of the general type of Figure 3 are connected in series by an intermediate material such as solder 406. This can be done for any of three principal purposes: (1) reduce the power per unit area produced by the assembly; (2) reduce thermal shear stresses; and (3) make the assembly thicker and more rugged. The first purpose is important since costs of fabricating heterostructure TE material

increase substantially as the number of layers increases. Furthermore, added layers increase fabrication complexity and reduce yields.

It is important to have the ability to adjust power levels to meet the demands of particular applications. If all else is equal, power density is inversely proportional to TE material thickness. Since hetrostructures are most easily made thin, power densities can be over 700 watts/square centimeter, which is hundreds of times more than that of typical TE modules fabricated from bulk materials. The high heat fluxes that can result can be difficult to transport without substantial losses. As a result, TE performance can be reduced so as to partially or completely negate the higher intrinsic TE performance of the hetrostructures. By fabricating devices from multiple hetrostructures, the TE material is thicker and power density can be reduced. TE performance is reduced by the electrical and thermal resistivity of the intermediate materials, electrodes, solder and other materials in electrical series with the TE material, but such losses are minimized advantageously by careful choice of the materials and how they are mated together. Thermal shear stresses are reduced by making the physical distance between the cold electrode and the hot electrode larger, using multiple layers of the hetrostructures, and by choosing materials throughout the assembly that have low coefficients of thermal expansion. Also, stresses can be reduced by utilizing intermediate materials that flex easily, such as conductive rubbers, or materials that contain fluids, conductive greases, mercury, other conductive liquids, and any other material that so that they do not transmit significant shear stresses.

The third purpose of increased thickness is to make the assembly more rugged so that it can withstand subsequent processing, handling, usage and the like. Also, its durability and stability can be increased by cladding and encapsulating or otherwise protecting sensitive constituent materials.

In Figure 4, the TE materials 403 and 409 may themselves be layers of hetrostructure TE materials as in Figures 1, 3, 5, and 6.

Figure 5 depicts a TE element portion 500 formed of hetrostructure thermoelectric material or thin film layers of thermoelectric material with a first electrode 501, bonding materials 502, 506 and 507, TE plates 503 and 505, and a second electrode 504. The TE plates 505 have gaps 509 due to defects or manufacturing tolerances of the TE plates 503 and

505, joints between the plates, or the assembly of many small TE plates into a larger array or the like. Advantageously, the TE plates 503 and 505 are hetrostructures of TE material and the bonding materials 502, 506, 507 generally cover the surfaces of the TE plates 503 and 505, fill the gaps 509 and electrically connect the plates in the direction of current flow 508. The bonding materials 502, 506 and 507 can be made of multiple materials as discussed in the description of Figures 2 and 3. In this embodiment, the bonding materials 502, 506 and 507 should have moderate to very high electrical and thermal conductivity. If many gaps 509 exist, electrical conductivity of the bonding materials at 506 and 507 and between the stacked plates 503 and 505 should be moderate. In this case, conductivity should not be so high and bonding material thickness so great that significant current flow 508 is shunted through the gaps 509 in the plates 505 rather than through the TE plates.

Figure 6 depicts a TE element portion 600 with electrodes 601, intermediate materials 602, TE plates 603 and 604, and gap 605 in a TE plate 604. In addition, bonding materials 608 are depicted between the TE hetrostructure layers 603, 604.

As in Figures 3, 4 and 5, current 606 passes through the TE element portion 600 generally upward. In this design, two features are presented. First, the TE plates 603 and 604 are fabricated with an outer layer, not shown, that when processed by heat and pressure or other suitable means, causes the plates 603 and 604 to adhere to one another so as to allow current to pass generally uniformly and with very low electrical resistance through the entire TE element 600. Alternately, and as shown in Figure 6, bonding material 608 can be used to the hetrostructure layers 603 and 604.. The intermediate materials 602 make similar low electrical and thermal resistance connections to the electrodes 601. Second, if the gaps 605 occur sufficiently infrequently in the TE element 600, no special provisions need be incorporated to enhance current flow in them. Similarly, the intermediate material could be omitted if the bond characteristics between the electrodes 601 and plates 603 are suitable for the conditions discussed related to Figure 6. Advantageously the TE layers 603, 604 are hetrostructure thermoelectric material or thin layers of thermoelectric material.

Figure 7 depicts a TE element 700 with electrodes 701, hetrostructure TE plates 702, 703, and bonding materials 704, 706. The current 707 flows generally parallel to a long dimension of the plates 702 and 703. In this configuration, if either a significant number of

gaps 705 (or breaks) in the heterostructure plates 703 are present or the number of plates 702 and 703 in the stack is small and some gaps 705 or breaks exist, the current 707 will be diverted by the gaps 705, unless the bonding material 704 and 706 (1) fills the gaps 705, (2) possesses the appropriate degree of electrical conductivity, (3) makes good electrical contact between the gaps 705 and the conductive layers that comprise part of the plates 703, and (4) does not contribute significantly to overall electrical and thermal losses in the TE element. Advantageously, distortion of the current flow 708 can be minimized by utilizing a bonding material 704 with electrical and thermal conductivity somewhat lower than that of the TE plates 702 and 703 in the direction of current flow 707. The bonding materials 706 and 704 need to be thin enough or otherwise configured so that they do not contribute significantly to the TE elements' overall electrical or thermal conductivity and thereby reduce TE efficiency.

If the gaps 705 occur sufficiently infrequently, the bonding material 704 and 706 need not fill the gaps 705, and only need to provide electrical continuity between adjacent plates 702 and 703 so that the current 708 can be accommodated without significant distortion from the infrequent gaps 705 or breaks, as was discussed in the description of Figure 6.

The TE plates 702, 703 may also be formed of thin layers of thermoelectric material. As mentioned above, the bonding material is also advantageously selected to reduce the shear stresses in the element. For example, flexible or otherwise resilient bonding material may be advantageous in some circumstances.

Table 1 presents a summary of the advantageous characteristics of sleeve, bonding material and intermediate materials. Notwithstanding the guidance presented in Table 1, other considerations or alternative design details may alter the teachings. Thus, Table 1 does not limit the scope of the present invention, but serves instead to give general design guidance.

MATERIAL PARAMETER	DIRECTION OF CURRENT FLOW							
	Parallel				Perpendicular			
	S	BM ₁	BM ₂	IM	S	BM ₁	BM ₂	IM
Thermal Conductivity	L	L	L	H	L	H	M	H
Electrical Conductivity	L	L	M	H	L	H	M	H
Thickness	L	L	L	OPT	L	OPT	L	OPT

L = Low; M = Medium; H = High; OPT = Optional

S = Sleeve; BM₁ = Bonding Material insignificant gaps;

BM₂ = Bonding Material significant gaps; IM = Intermediate Material

Table 1

It should be understood that the thickness of the intermediate and bonding materials is generally indicated to meet the desired thermal and electrical characteristics of these layers. As will be understood from the above description, both the thermal conductance and thermal conductivity of these materials is taken into account in selecting the thickness and other properties of these materials.

Although several examples of thermoelectric compositions using the hetrostructures and binding concepts described herein, the above-described embodiments are merely illustrative and variations from these could be made. For example, thin layers of TE material could be used rather than hetrostructures in any embodiment. Further, features described in any one figure could be combined with features of any other figure, if appropriate, to achieve an advantageous combination in a particular device. Such combinations are also the objects and teachings of the present invention. Accordingly, the invention is defined by the appended claims, wherein the terms used are given their ordinary and accustomed meaning with no particular or special definition attributed to those terms by the specification.